



Attorney Docket No. 63254-5002-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. of:	Robert J. SMALL and Zhefei J. CHEN	Confirmation No:	1702
Serial No:	10/057,206	Group:	1755
Filed:	January 25, 2002	Examiner:	M. Marcheschi
Entitled:	<b>Compositions for Chemical Mechanical Planarization of Noble-Metal-Featured Substrates, Associated Methods, and Substrates Produced by Such Methods</b>		
		Atty Docket:	63254-5002-US

**RESPONSE UNDER 37 C.F.R. §1.111**

U.S. Patent and Trademark Office  
Randolph Building  
401 Dulany Street  
Alexandria, Virginia 22314  
**MAIL STOP – AMENDMENT**

Sir:

In response to the Office Action mailed on December 28, 2006, please consider the following amendments and remarks:

A list of the pending claims begins on page 2 of this Response; and  
Remarks begin on page 10 of this response.